

FORM PTO-1449 U. S DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)	ATTY. DOCKET NO.	SERIAL NO.
	U 01585	10/542,123
	APPLICANT	
	Vladimir Pavlovich POPOV et al.	
	FILING DATE	GROUP
	12/9/05	2823

U.S. PATENT DOCUMENTS

EXAMINER INITIALS	REFERENCE DESIGNATION	DOCUMENT NUMBER	DATE	NAME	FILING DATE IF APPROPRIATE
QVJ	AA	6,323,109	11/2001	Okonogi	
QVJ	AB	6,306,730	10/2001	Mitani et al.	
QVJ	AC	5,374,564	12/1994	Bruei	
	AD				
	AE				
	AF				
	AG				
	AH				
	AI				
	AJ				
	AK				

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
QVJ	AL	2 164 719	03/2001	RU	X	
QVJ	AM	197 53 494	10/1998	DE		X
	AN					
	AO					
	AP					

OTHER ART (Including Author, Title, Date, Pertinent Dates, Etc.)

QVJ	AQ	Partial English Translation of RU 2 164 719 dated March 27, 2001
QVJ	AR	Tong, Q.-Y., et al. "Semiconductor Wafer Bonding: Science and Technology" A Wiley-Interscience Publication, pp 52 and 62
	AS	

EXAMINER Quovaunda Jefferson DATE CONSIDERED 06/05/2006

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.